



2826
JFW
PATENT
8005-1004

IN THE U.S. PATENT AND TRADEMARK OFFICE

In re application of

Koichi OHTO et al.

Conf. 1071

Application No. 09/883,370

Group 2826

Filed June 19, 2001

Examiner F. Erdem

SEMICONDUCTOR DEVICE AND METHOD
AND APPARATUS FOR MANUFACTURING
THE SAME

AMENDMENT

Assistant Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

September 30, 2004

Sir:

In response to the Official Action mailed June 30, 2004, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 4 of this paper.